Institut für Fertigungstechnik und Werkzeugmaschinen Prof. Dr.-Ing. Berend Denkena

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Introduction



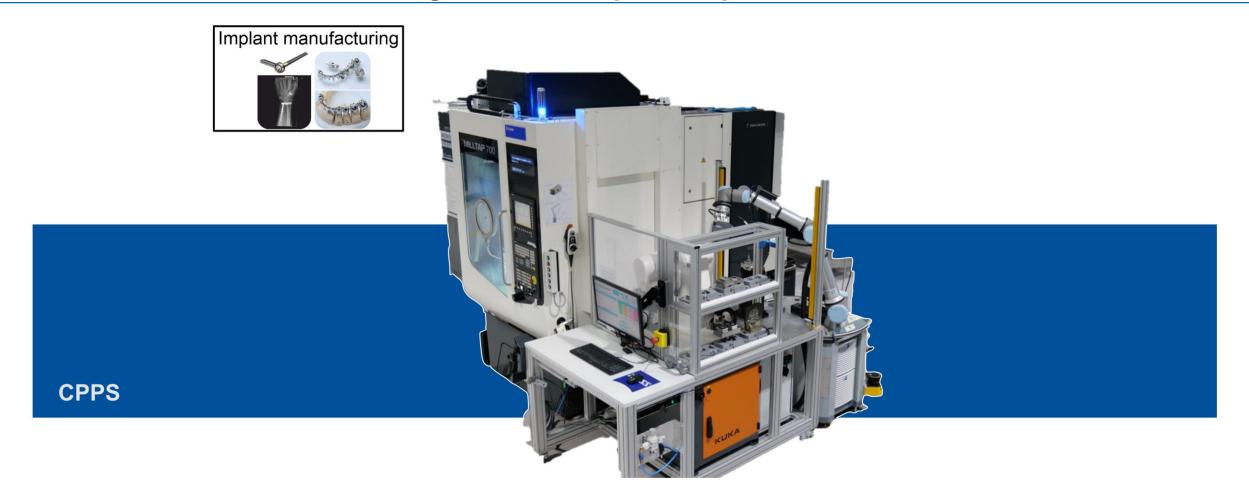








Semi-autonomous manufacturing cell for orthopedic implants





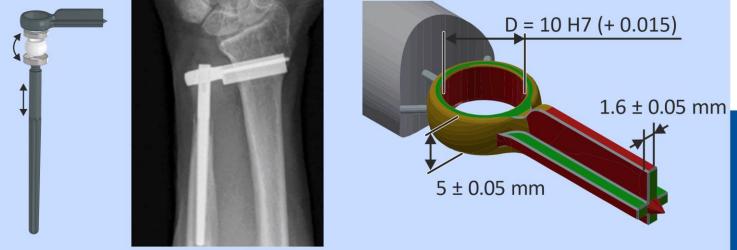


Semi-autonomous manufacturing cell for orthopedic implants





Distal radioulnar joint endoprosthesis



- Material: Ti6AI7Nb
- Manufacturing in very small batches
- CAM planning with Siemens NX
- Production time approx. 40 minutes, number of tools: 6

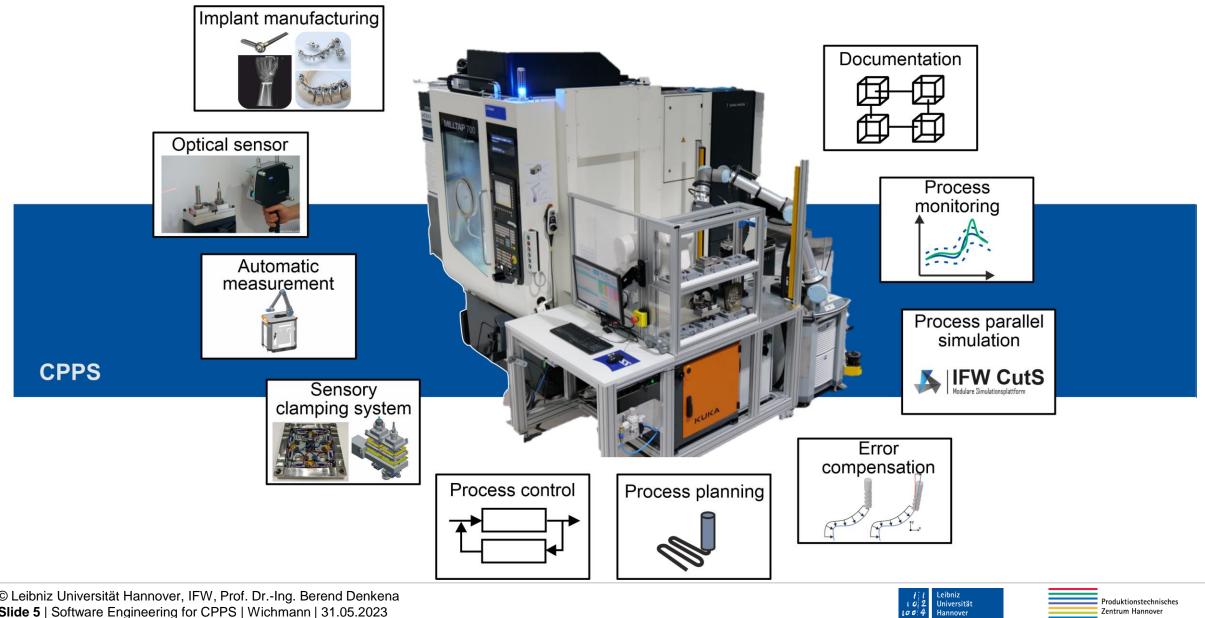




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Semi-autonomous manufacturing cell for orthopedic implants



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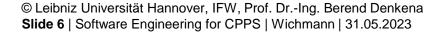
Benefits and software engineering challenges

Benefits of a semi-autonomous manufacturing cell

- Automatic quality control
- Automated process planning
- Process control and error compensation
- Teach-in-free process monitoring
- Compliance with regulatory requirements

Software engineering challenges

- System and information complexity
- Product variability and Multidisciplinarity
- Knowledge management
- Data Analytics & AI (transfer learning, active learning, ...)















Institute of Production Technology and Machine Tools (IFW)







Adaptive process planning in implant manufacturing



Digital Implant Lifecycle Management









Competencies of the IFW



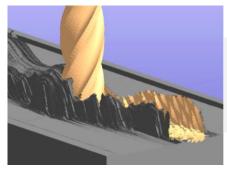


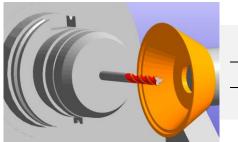


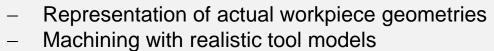




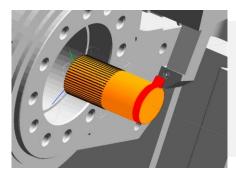
Technological NC-Simulation in IFW CutS







Modelling of complex kinematic movements Analysis of local cutting conditions



- Specific workpiece models
- Integration of further technological models
- Simulation of additive and subtractive manufacturing

Material removal by using a dexel model



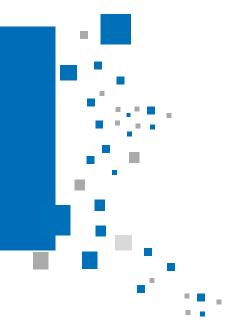








Autonomous machine tool







Autonomous machine tool The five levels of autonomous production



Stage 0 Worker only	Stage 1 Monitored	Stage 2 Automised	Stage 3 Semi-autonomous	Stage 4 Autonomous
Worker	Extensive process monitoring	Process control (e.g. force)	Machine tool plans processes on its own for certain operations	Machine tool plans and controls machining operations on its own and learns continuously
No systems active	Worker does not need to monitor the process permanently	Unexpected process conditions are controlled within a pre-defined control window	Unexpected process conditions are controlled by a learning process control	Machine tools can be embedded into autonomous systems of higher order

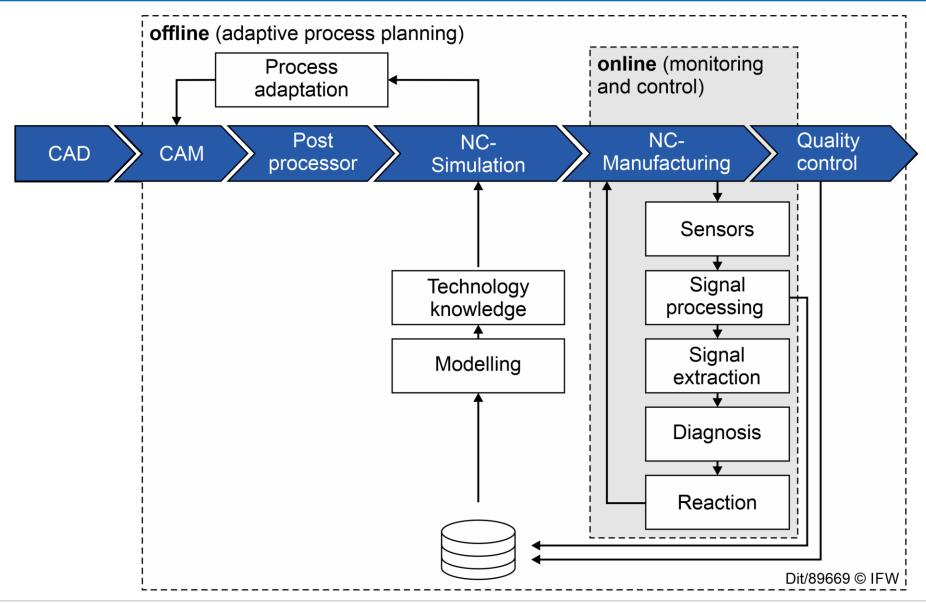
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Control loops in an autonomous machine tool









Adaptive process planning

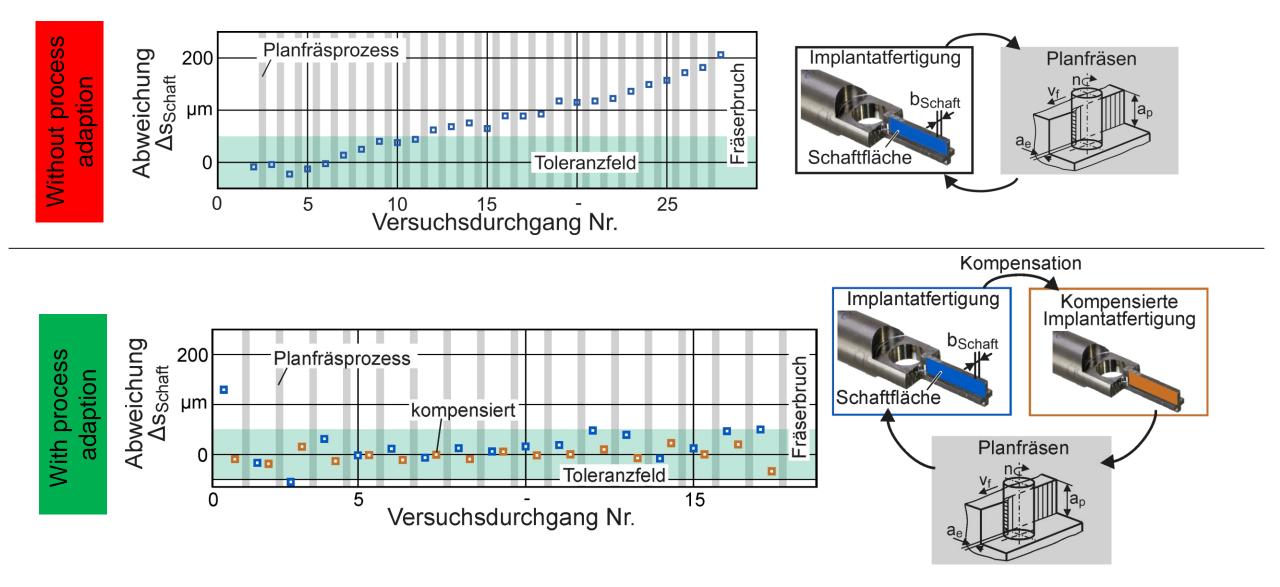
in implant manufacturing







Process adaption for error compensation in series production









Produktionstechnisches

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Al-based self-learning process adaptation

Problem definition

- Manufacturing data is not merged
- Knowledge remains at experienced staff
- Assistance systems in process planning are rigid

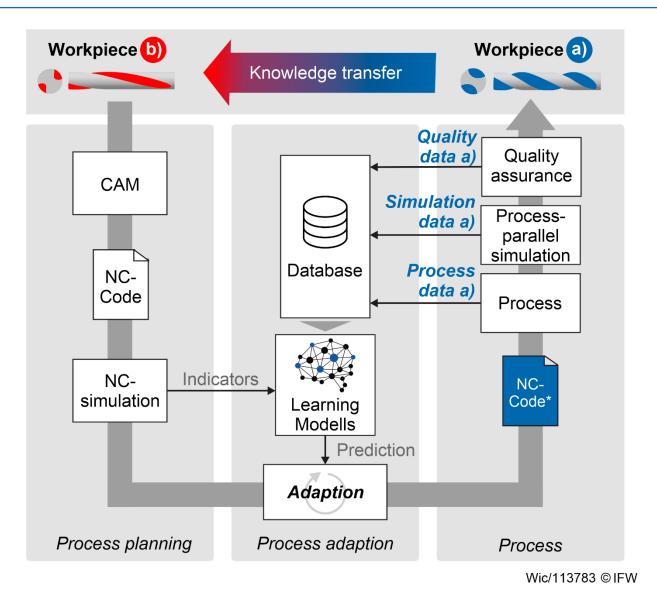
Objective

- Combination of different data types
- Simulation based process adaption
- Knowledge transfer to save resources

Approach



AI-based self-learning process adaptation by using digital twins in process planning







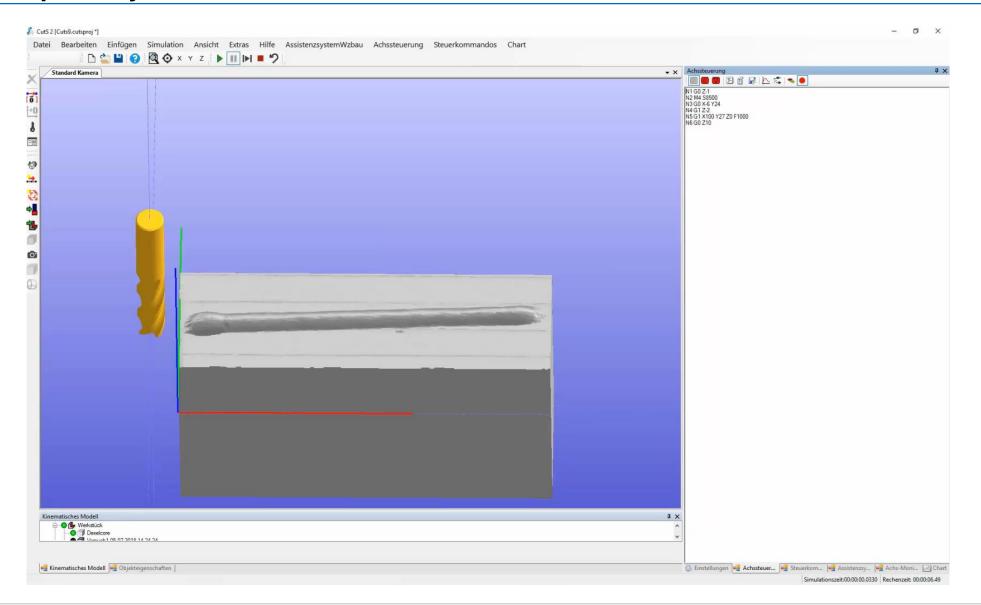
Automated process planning (CAM)

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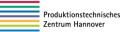




Process adaption by NC-simulation

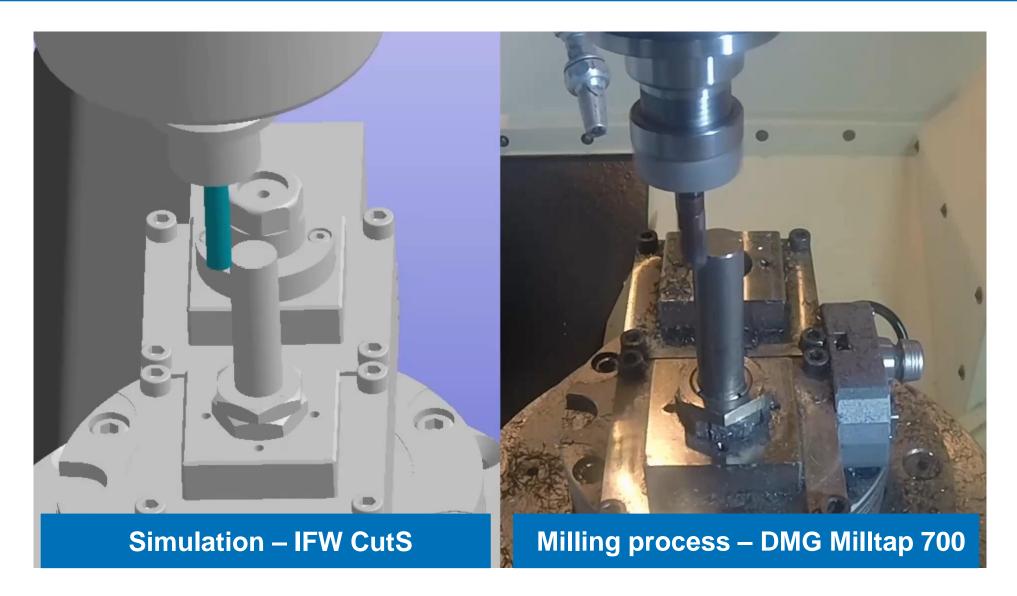








Process parallel simulation as a soft sensor









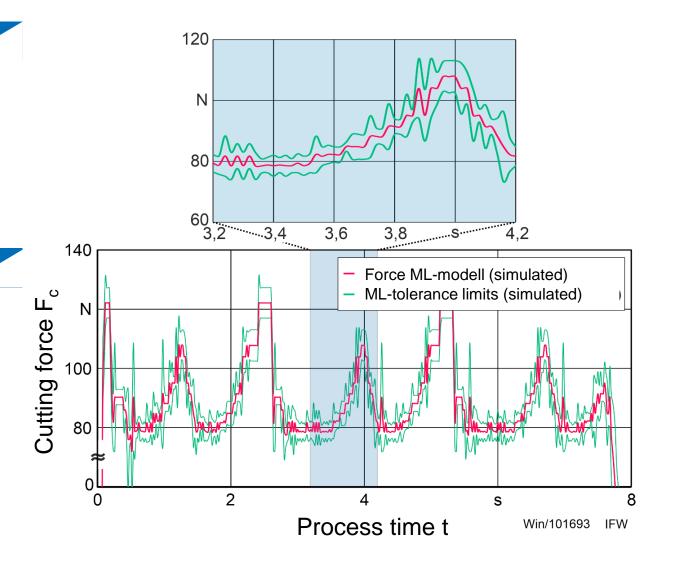
Process monitoring using simulation approaches

Set monitoring limits by a process simulation

- Force prediction by ML-Modell (ML.Net)
- Limit corresponds to the standard deviation of the modeled process forces

Process monitoring using IFW CutS

- Forces are measured in the cutting process and transferred to IFW CutS in real time
- If the limits are exceeded, the CNC machine is stopped automatically by IFW CutS.







Video of process monitoring (IFW CutS)

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Digital Implant Lifecycle Management







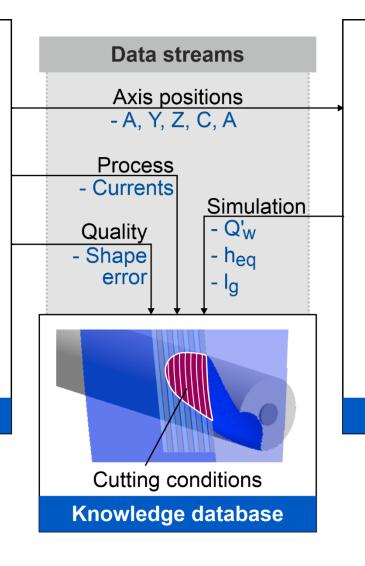


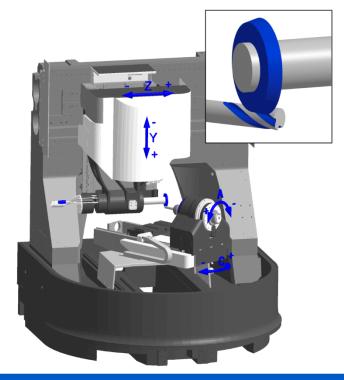
Approach for single processes – Digital Twin in tool grinding



Manufacturing

- Machine control transfers axis data, spindle current and axis currents in 200 Hz
- Sensor data can be used additionally





Material removal simulation

- Process-parallel material removal simulation uses the real axis data
- Calculation of the local cutting conditions

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Aproach for process chains – Repair procedures for aircraft engines

Regeneration of complex capital goods Reale Ebene Autragseinge Virtueller Werkstück-Virtuelle Ebene zwilling Berechni



- Digitalization:
 Real level of the repair process
 virtual level of the digital twin
- Consideration: Functional benefit of repairs
- Benefits: Automated decision making in complex systems



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Additive Manufacturing – Deposition welding process



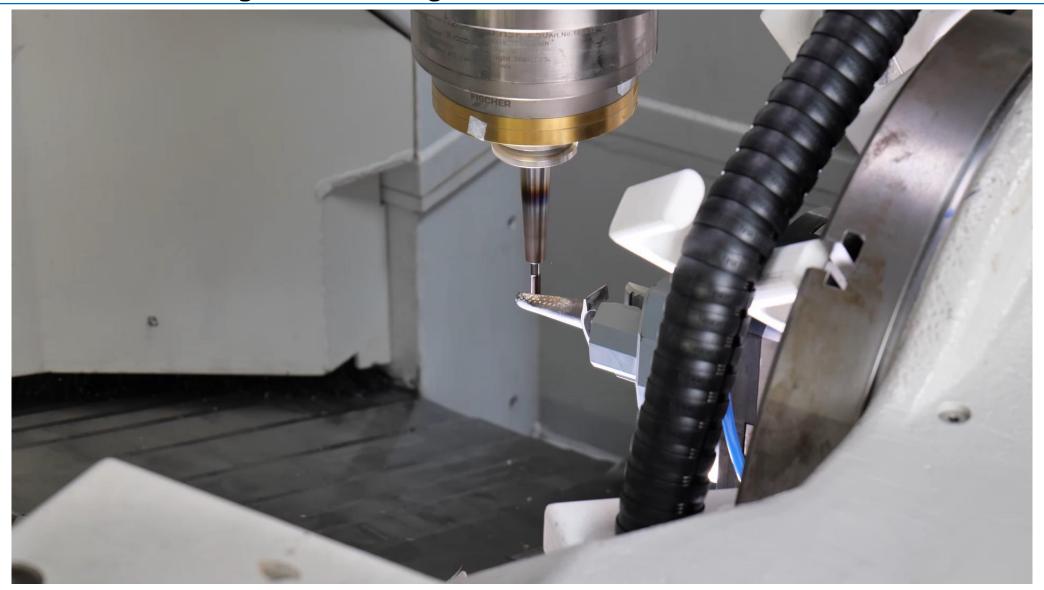








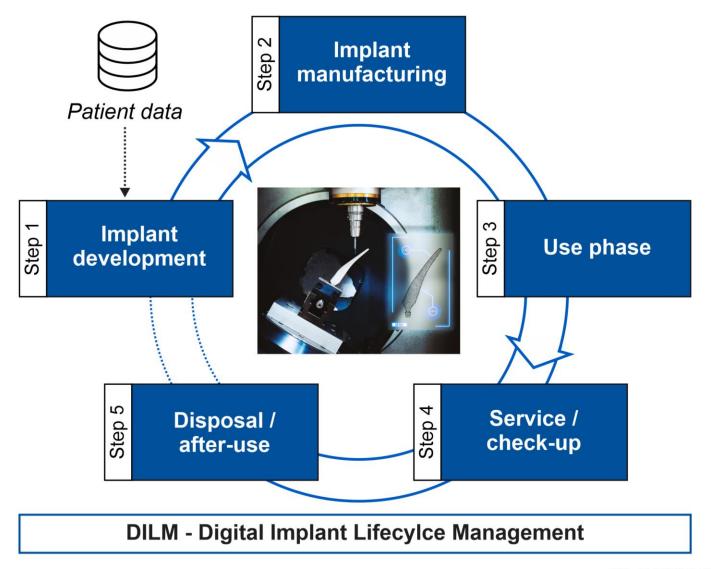
Subtractive Manufacturing: Recontouring







Digital Implant Lifecycle Management



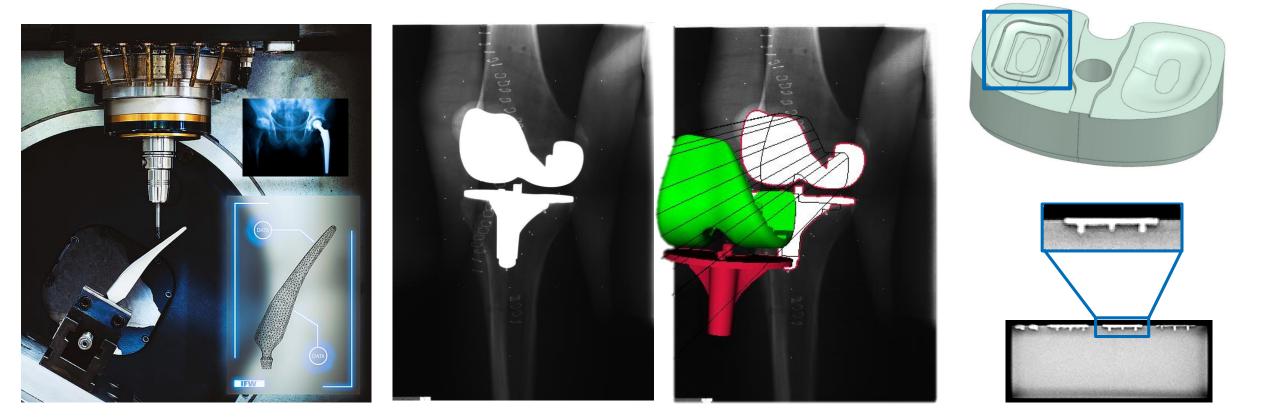
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Open question for the discussion: How can data formats be combined?





Feeding, processing and simulation of data into the Digital Twin before, during and after the use of the implant helps to improve manufacturing, monitoring and patient well-being.







Software Engineering for CPPS





General trends

- Economical production in high-wage countries
- Flexible but also highly automated production systems
- Variations in machine tools (age, component manufacturers)

Challenges regarding digitalization

- Interfaces between different software systems
- Data management (type and location of storage)
- Different data sources and differences in the frequency of data
- Computer scientists must assist with data science









- Software architects (for specific domains)
- System design \rightarrow Development of an algorithm
- Communication of the problem and interface to other departments \rightarrow Shape shifters
- Collect requirements (method,...), requirement moderators neutral interface
- Detailed program flow chart \rightarrow Specifications for programming
- Implementation (technical rough realizers), Keyword: Iterative implementation
- Prototype development and pre-development
- VDI guideline 2221
- Unbiased approach
- \rightarrow What is the requirement for a CPPS?





Conclusion





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Thank you for your attention

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